



TRANSMITTAL FORM

(to be used for all correspondence after initial filing)

		Application Number	10/644,644
		Filing Date	August 19, 2003
		First Named Inventor	Henley, Francois J.
		Art Unit	Unassigned
		Examiner Name	Unassigned
Total Number of Pages in This Submission	16	Attorney Docket Number	018419-000183US

ENCLOSURES (Check all that apply)

<input type="checkbox"/> Fee Transmittal Form <input type="checkbox"/> Fee Attached <input type="checkbox"/> Amendment/Reply <input type="checkbox"/> After Final <input type="checkbox"/> Affidavits/declaration(s) <input type="checkbox"/> Extension of Time Request <input type="checkbox"/> Express Abandonment Request <input checked="" type="checkbox"/> Information Disclosure Statement (2 pgs) w/attached PTO/SB/08A (9 pgs), citing references 1-254, and PTO/SB/08B (3 pages) citing references 255-287 <input type="checkbox"/> Certified Copy of Priority Document(s) <input type="checkbox"/> Response to Missing Parts/ Incomplete Application <input type="checkbox"/> Response to Missing Parts under 37 CFR 1.52 or 1.53	<input type="checkbox"/> Drawing(s) <input type="checkbox"/> Licensing-related Papers <input type="checkbox"/> Petition <input type="checkbox"/> Petition to Convert to a Provisional Application <input type="checkbox"/> Power of Attorney, Revocation Change of Correspondence Address <input type="checkbox"/> Terminal Disclaimer <input type="checkbox"/> Request for Refund <input type="checkbox"/> CD, Number of CD(s)	<input type="checkbox"/> After Allowance Communication to Group <input type="checkbox"/> Appeal Communication to Board of Appeals and Interferences <input type="checkbox"/> Appeal Communication to Group (Appeal Notice, Brief, Reply Brief) <input type="checkbox"/> Proprietary Information <input type="checkbox"/> Status Letter <input checked="" type="checkbox"/> Other Enclosure(s) <small>(please identify below):</small> Return Postcard	
		Remarks	The Commissioner is authorized to charge any additional fees to Deposit Account 20-1430.

SIGNATURE OF APPLICANT, ATTORNEY, OR AGENT

Firm or Individual	Townsend and Townsend and Crew LLP Tyrome Y. Brown	
Signature		
Date	January 14, 2004	

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PATENT
Attorney Docket No.: 018419-000183US

TOWNSEND and TOWNSEND and CREW LLP

By: Edward Masinas
Edward Masinas

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Francois J. Henley et al.

Application No.: 10/644,644

Filed: August 19, 2003

For: CONTROLLED CLEAVING
PROCESS

Examiner: Not Yet Assigned

Art Unit: Not Yet Assigned

**INFORMATION DISCLOSURE
STATEMENT UNDER 37 CFR §1.97 and
§1.98**

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

The references cited on attached form PTO/SB/08A and PTO/SB/08B are being called to the attention of the Examiner. In accordance with 37 CFR §1.98(d), copies of the references can be found in Application No. 09/483,393, now U.S Patent 6,632,724 B2, issued October 14, 2003 (Attorney Docket No. 018419-000182US). It is respectfully requested that the cited references be expressly considered during the prosecution of this application, and the references be made of record therein and appear among the "references cited" on any patent to issue therefrom.

As provided for by 37 CFR 1.97(g) and (h), no inference should be made that the information and references cited are prior art merely because they are in this statement and no representation is being made that a search has been conducted or that this statement encompasses all the possible relevant information.

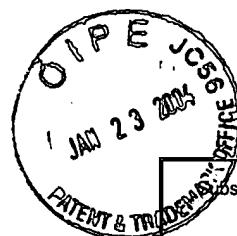
Applicant believes that no fee is required for submission of this statement. However, if a fee is required, the Commissioner is authorized to deduct such fee from the undersigned's Deposit Account No. 20-1430. Please deduct any additional fees from, or credit any overpayment to, the above-noted Deposit Account.

Respectfully submitted,



Tyrome Y. Brown
Reg. No. 46,580

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60070501 v1



Institute for form 1449A/PTO				Complete if Known	
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Sheet	1	of	12	Attorney Docket Number	018419-000183US

U.S. PATENT DOCUMENTS+					
Examiner Initials*	Cite No. ¹	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number Kind Code ² (if known)			
	1	2,614,055	10/1952	Senarelens	
	2	3,117,022	01/1964	Bronson et al.	
	3	3,225,820	12/1995	Riordan	
	4	3,390,033	06/1968	Brown	
	5	3,551,213	12/1970	Boyle	
	6	3,770,499	10/1973	Crowe et al.	
	7	3,786,359	01/1974	King	
	8	3,806,380	04/1974	Kitada et al.	
	9	3,832,219	08/1974	Nelson et al.	
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	11	3,901,423	08/1975	Hillberry et al.	
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	14	3,957,107	05/1976	Altoz et al.	
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	16	4,006,340	02/1977	Gorinas	
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	19	4,074,139	02/1978	Pankove	
	20	4,107,350	08/1978	Berg et al.	
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	23	4,121,334	10/1978	Wallis	
	24	4,170,662	10/1979	Weiss et al.	
	25	4,216,906	08/1980	Olsen et al.	
	26	4,237,601	12/1980	Woolhouse et al.	
	27	4,244,348	01/1981	Wilkes	
	28	4,252,837	02/1981	Auton	
	29	4,255,208	03/1981	Deutscher et al.	
Examiner Signature			Date Considered		

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. ¹ Applicant's unique citation designation number (optional). ² Kind Codes of U.S. Patent Documents at www.uspto.gov or MPEP 901.04. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁶ Applicant is to place a check mark here if English language Translation is attached.



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		Number Kind Code ² (if known)			
	30	4,274,004	06/1981	Kanai	
	31	4,342,631	08/1982	White et al.	
	32	4,346,123	08/1982	Kaufmann	
	33	4,361,600	11/1982	Brown	
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	38	4,468,309	08/1984	White	
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	40	4,486,247	12/1984	Ecer et al.	
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	52	4,704,302	11/1987	Bruel et al.	
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	58	4,837,172	06/1989	Mizuno et al.	
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60070501 v1



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	59	4,846,928	07/1989	Dolins et al.	
	60	4,847,792	07/1989	Barna et al.	
	61	4,853,250	08/1989	Boulos et al.	
	62	4,883,561	11/1989	Gmitter et al.	
	63	4,887,005	12/1989	Rough et al.	
	64	4,891,329	01/1990	Reisman et al.	
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	70	4,960,073	10/1990	Suzuki et al.	
	71	4,982,090	01/1991	Wittmaack	
	72	4,983,251	01/1991	Haisma et al.	
	73	4,996,077	02/1991	Moslehi et al.	
	74	5,015,353	05/1991	Hubler et al.	
	75	5,034,343	07/1991	Rouse et al.	
	76	5,070,040	12/1991	Pankove	
	77	5,082,793	01/1992	Li	
	78	5,102,821	04/1992	Moslehi	
	79	5,110,748	05/1992	Sarma	
	80	5,133,826	07/1992	Dandl	
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	82	5,196,355	03/1993	Wittkower	
	83	5,198,371	03/1993	Li	
	84	5,202,095	04/1993	Houchin et al.	
	85	5,203,960	04/1993	Dandl	
	86	5,206,749	04/1993	Zavracky et al.	
	87	5,213,451	05/1993	Frank	
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60070501 v1



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Examiner Initials*	Cite No. ¹	Number Kind Code ² (if known)			
	88	5,234,529	08/1993	Johnson	
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	98	5,277,748	01/1994	Sakaguchi et al.	
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	116	5,413,679	05/1995	Godbey	
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60070501 v1



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	117	5,435,880		07/1995 Minato et al.	
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	130	5,558,718		09/1996 Leung	
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	144	5,763,319		06/1998 Ling et al.	
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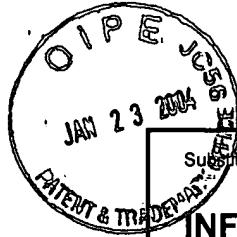


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		Number Kind Code ² (if known)			
	146	5,804,086	09/1998	Bruel	
	147	5,821,158	10/1998	Shishiguchi	
	148	5,824,595	10/1998	Igel et al.	
	149	5,827,751	10/1998	Nuyen	
	150	5,840,590	11/1998	Myers, Jr. et al.	
	151	5,854,123	12/1998	Sato et al.	
	152	5,869,387	02/1999	Sato et al.	
	153	5,877,070	03/1999	Goesele et al.	
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	163	6,013,563	01/2000	Henley et al.	
	164	6,020,252	02/2000	Aspar et al.	
	165	6,033,974	03/2000	Henley et al.	
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	168	6,083,324	07/2000	Henley	
	169	6,120,597	09/2000	Levy et al.	
	170	6,150,239	11/2000	Goesele et al.	
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	174	6,190,998	02/2001	Bruel et al.	
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	177	6,225,192	05/2001	Aspar et al.	

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		Country Code ³	Number ⁴	Kind Code ⁵ (if known)				
	178	DE	0834363		03/1952			
	179	EP	0112 230	A1	04/1987			
	180	EP	0181249		06/1989			
	181	EP	0504714		09/1992			
	182	EP	0533551		03/1993			
	183	EP	0379828		09/1995			
	184	EP	0459177		12/1995			
	185	EP	0703609		03/1996			
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	188	EP	0867921		03/1998			
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	191	EP	084 287	A1	07/1983			
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<p>Substitute for form 1449A/PTO</p> <p>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</p> <p>(use as many sheets as necessary)</p>				Complete if Known	
				Application Number	10/644,644
				Filing Date	August 19, 2003
				First Named Inventor	Henley, Francois J.
				Art Unit	Not Yet Assigned
				Examiner Name	Not Yet Assigned
Sheet	8	of	12	Attorney Docket Number	018419-000183US

FOREIGN PATENT DOCUMENTS							
Examiner Initials *	Cite No. ¹	Foreign Patent Document		Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ⁶
		Country Code ³	Number ⁴				
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**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT**

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Sheet	10	of	12	Attorney Docket Number	018419-000183US
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Compl. te if Known

Application Number	10/644,644
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